

Lewis Acid Mediated Functionalization of Porous Silicon with Substituted Alkenes and Alkynes

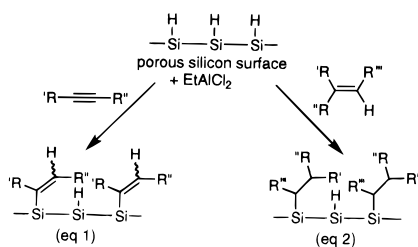
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Silicon surface chemistry is of fundamental importance because of the ubiquitous role of silicon in modern technology and yet is only just beginning to be investigated.¹ Virtually all microprocessor chips in electronic products are based upon crystalline silicon wafers.² Control of silicon surface chemistry is crucial to allow access to technologically interesting thin films for fabrication of new electronic devices.³ Canham and co-workers showed in 1990 that silicon wafers could be etched to produce a microns-thick porous layer (termed porous silicon) which exhibits photoluminescence upon exposure to UV light.⁴ Potential applications for porous silicon include use as chemical sensors,⁵ optoelectronic devices⁶ such as electroluminescent displays,⁷ photodetectors,⁸ and as a matrix for photopumped tunable lasers.⁹ As a result, modification and characterization of photoluminescent porous silicon surfaces has become an area of intense interest.¹⁰ In this work we report a mild and general approach for covalent modification of the surface of porous silicon through EtAlCl₂ mediated hydrosilylation of readily available alkynes and alkenes which yields surface bound vinyl and alkyl groups, respectively, as outlined in eqs 1 and 2.¹¹



This method is tolerant of a wide variety of functional groups as has been demonstrated through the formation of nitrile, hydroxy, and ester terminated surfaces (Figure 1). Porous silicon functionalized with hydrophobic groups using this technique demonstrates remarkable stability to such adverse conditions as boiling aerated water and boiling aqueous KOH (pH 10).

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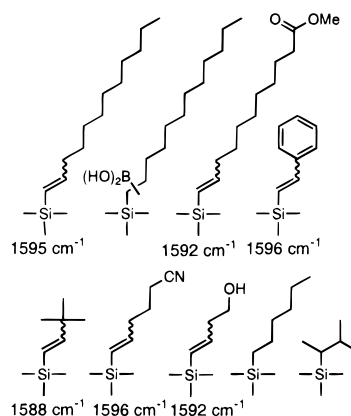


Figure 1. Functional groups covalently bound to the surface of porous silicon through EtAlCl₂ mediated hydrosilylation of alkynes and alkenes. The numeric values correspond to the ν (C=C) of the surface-bound vinyl group as measured by transmission FTIR.

Hydrosilylation of olefins and alkynes proceeds under a wide variety of reaction conditions. Commonly used late transition metal catalysts¹² were avoided because of the potential for activation of the weaker Si–Si bonds¹³ on the surface (bond strengths: Si–Si = 340 kJ/mol, Si–H = 393 kJ/mol).¹⁴ Lewis acid catalyzed or mediated reactions seemed ideal for functionalization of porous silicon because of the mild reaction conditions involved.¹⁵ AlCl₃ is known to be an effective catalyst for hydrosilylation of both alkynes¹⁶ and alkenes.¹⁷ Since EtAlCl₂ is soluble in nonpolar solvents whereas AlCl₃ is not, it was chosen as the Lewis acid to avoid multiphase reactions on the surface of porous silicon.¹⁸ Addition of 10 μ L of a commercial 1.0 M hexanes solution of EtAlCl₂ (10 μ mol) to a 0.28 cm² area of porous silicon (galvanostatically etched, n type, P-doped, (100) orientation, 0.83 ohm·cm resistivity Si wafer, 75 mA/cm² current density with illumination by a 300 W tungsten filament bulb, 1:1 solution of EtOH/49% aqueous HF) followed by 3 μ L of 1-dodecyne (14 μ mol) under nitrogen resulted in clean incorporation of dodecyl groups on the surface in 1 h at room temperature as shown by transmission FTIR (Figure 2a). The resulting disubstituted carbon–carbon double bond appears at 1595 cm^{−1}. Neither the stereochemistry nor ratio of possible regioisomers of surface-bound olefins were determined, but molecular hydrosilylation of alkynes catalyzed by EtAlCl₂ yields exclusively cis alkenes with perfect regioselectivity when the alkyne is terminal (100% anti-Markovnikov addition), as are all the alkynes examined here.¹⁶ The C=C stretching frequency of the surface bound dodecyl group correlates well with that reported for the related molecular compound, (Z)-1-triethylsilyl-1-dodecene (1605 cm^{−1}), also produced through hydrosilylation of 1-dodecyne with triethylsilane catalyzed by EtAlCl₂.¹⁶ Other pertinent features observed by FTIR include the ν (C–H) stretches of the decyl chain between 2960 and 2850 cm^{−1} and δ (C–H) methylene and methyl bending modes at 1466 and 1387 cm^{−1}. Hydrophobic

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